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CONFIRMATION NO. 8498

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| APPLICANTS | | | | | | | | | | |
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| ** CONTINUING DATA ********************************** | | | | | | | | | | |
| This application is a CIP of 10/164,327 06/05/2002 PAT 6,939,434 / WOTC ** FOREIGN APPLICATIONS ************************************ | | | | | | | | | | |
| 11/14/2003 Foreign Priority claimed | | | | | | | | | | |
| Foreign Priority claimed 35 USC 119 (a-d) conditi Verified and Acknowledg | STATE OR COUNTRY CA | | | CLA | TAL AIMS 58 | INDEPENDENT CLAIMS 1 | | | | |
| Verified and Acknowledged Examiner's Signature Initials ADDRESS Patent Counsel, M/S 2061 Legal Affairs Dept. Applied Materials, Inc. P.O. Box 450-A Santa Clara, CA95035 | | | | | | | | | | |
| TITLE Plasma immersion ion implantation apparatus including an inductively coupled plasma source having low dissociation and low minimum plasma voltage | | | | | | | | | | |
| | | | | | | | ☐ All Fees | | | |
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